

# AESF/EPA Conference Marks 20th Anniversary On January 25–27, 1999

## Congressman Boehlert (R-NY) Will Give Keynote Address At AESF/EPA Conference



Congressman Sherwood Boehlert, chairman of the Subcommittee on Water Resources and the Environment, will be the keynote speaker at the AESF/EPA Con-

ference for Environmental Excellence, January 25–27, at Disney's Coronado Springs Resort, Lake Buena Vista, FL. (The keynote address is scheduled for 9:30 a.m. on Monday, January 25.)

Congressman Boehlert, known to all as "Sherry," was elected to represent Central New York in the House in 1982, and has received increasing national attention in recent years as the absolutely pivotal House leader on environmental issues.

In addition to his responsibility on the very important Committee on Transportation and Infrastructure, (chairman of the Subcommittee on Water Resources and the Environment), Congressman Boehlert is also a member of the Committee on Science, serving on the Subcommittee on Basic Research. Congressman Boehlert's independence and moderation reflect the diversity of his large district. He has consistently focused his efforts on Capitol Hill on what he calls "the three Es"—the environment, economic development and education.

Congressman Boehlert became interested in environmental protection as he saw firsthand the devastation that acid rain wreaked on the Adirondack Mountains. Drawing from this, he first rose to national prominence in 1990 as the co-author of the acid rain provision in the Clean Air Act amendments passed that year.

Congressman Boehlert holds a BS from Utica College and is former manager of public relations for Wyandotte Chemical. He holds honorary doctoral degrees from Colgate and Syracuse Universities.

Now going into its 20th year, the Conference sponsored by the American Electroplaters and Surface Finishers Society (AESF) and the U.S. Environmental Protection Agency (EPA) is a one-of-a-kind, well-established forum that encourages government and industry representatives to talk to each other and share information on cost-effective, successful, innovative environmental strategies. Formerly known as the Conference on Pollution Prevention and Control for the Metal Finishing Industry, the event has been renamed the "Conference for Environmental Excellence" to reflect environmental progress made through the cooperative efforts of industry and government.

## Conference Will Address Two Important Themes

The AESF/EPA Conference has traditionally been strong on give-and-take interaction between speakers and audience—a real sharing of opinions and factual information. Two important themes will be thoroughly explored in the '99 Conference: Industry's evolving relationship with the EPA and a frank perspective on the innovative

Strategic Goals Program that came out of the Common Sense Initiative.

## Conference Organizers

The organizers of the 1999 Conference are E. Timothy Oppelt and David Ferguson of the National Risk Management Research Laboratory (NRMRL), U. S. Environmental Protection Agency (EPA), Cincinnati, OH, and Peter Gallerani, CEF, Integrated Technologies, Inc., Danville, VT. Also assisting with the program are Christian Richter and Al Collins of the AESF/NAMF/MFSA Government Relations office, Washington, DC, and Holly Evans, the Institute for Interconnecting and Packaging Electronic Circuits (IPC), Washington, DC.

## Proceedings/Course & Workshop Materials

A copy of the *Proceedings* of the 1999 AESF/EPA Conference is included in that conference registration fee. Please ask for your copy at the information booth in the AESF Registration Area.

Course and workshop materials are included in those respective registrations. Course/Workshop materials are usually distributed in their respective meeting rooms.



Key organizers for the AESF/EPA Conference are (L-R) E. Timothy Oppelt and David Ferguson, National Risk Management Research Laboratory, U.S. EPA, Cincinnati, OH, and Peter Gallerani, CEF, Integrated Technologies, Inc., Danville, VT.

**Be sure to read over the program!  
It has been updated for this issue.**